

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re:	De Simone <i>et al.</i>	Confirmation No.:	8879
Appl No.:	10/583,570	Group Art Unit:	1615
Filed:	3/5/07	Examiner:	H. Sheikh
For:	METHODS FOR FABRICATING ISOLATED MICRO- AND NANO- STRUCTURES USING SOFT OR IMPRINT LITHOGRAPHY		

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**RESPONSE TO RESTRICTION REQUIREMENT AND
PRELIMINARY AMENDMENT UNDER 37 CFR § 1.115**

In response to the Restriction dated October 4, 2010, please enter the following amendments in the above-identified application:

Amendments to the claims beginning on page 2 of this paper; and

Remarks beginning at page 21.